Electronic Acknowledgement Receipt FES ID: 1041375 Application Number: 10615794 Confirmation Number: 3511 Void-free damascene copper deposition process and means of Title of Invention: monitoring thereof First Named Inventor: Panayotis Andricacos Customer Number: 30678 Filer: John A. Evans/Lisa Hawkins Filer Authorized By: John A. Evans Attorney Docket Number: 20140-00302-US /YOR920030 Receipt Date: 08-MAY-2006 Filing Date: 10-JUL-2003 Time Stamp: 16:02:17 Application Type: Utility International Application Number:

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If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.

National Stage of an International Application under 35 U.S.C. 371

If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.